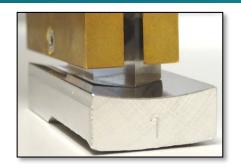
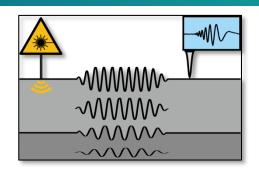
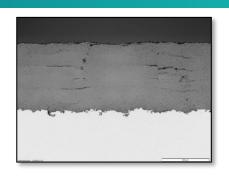


LAwave – Non-destructive characterization of coatings and material surfaces by laser-induced surface acoustic wave spectroscopy

Fraunhofer Institute for Material and Beam Technology IWS, Germany







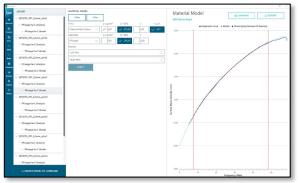




LAwave – at a glance











LAwave – Our one-of-a-kind measurement technology offers

- Access to surface material properties: Non-destructive, quick with highest accuracy
- For academia: unique research options for material science and solid state physics
- For industry: Easy quantification of surface properties in less than one minute
- Custom solutions for research, quality control, analysis and automation
- Fully integrated software for measurement and analysis

Facts and numbers

Complies with EN 15042-1:2006

30+ systems world wide

30+ years of experience

70+ peer reviewed contributions

2000+ citations

R&D 100 award





Contents

Introduction

Application Overview and How it works

Method

Measurement Principle, Evaluation Concepts, Material Models

Development and Background

Development, History

Case Studies

Semiconductor, PVD, Thermal Spray, Laser Cladding, Surface treatment, Comparison with Indentation, ...

Methodical Aspects

Roughness, Sample curvature, Comparison with Nanoindentation

Worldwide Contact





Introduction



Components and technologies

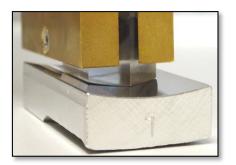
Mechanical properties of coated components

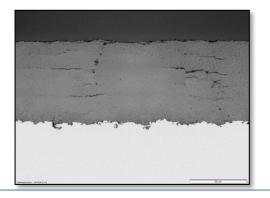
- Cylinder liner coatings (APS, wire arc spraying, ...)
- Electric heaters (thermal sprayed coatings)
- Brake disk coatings (laser cladding)
- Heavy duty gear parts (cemented carbide coatings)
- 3D-printed metal components (SLM)
- Piston pins, tappets, chain components (PVD)
- And many more....

For R&D and quality control

- Effective Modulus (Pores, cracks, voids, delamination)
- Thickness
- Homogeneity
- Fast and effective high throughput screening









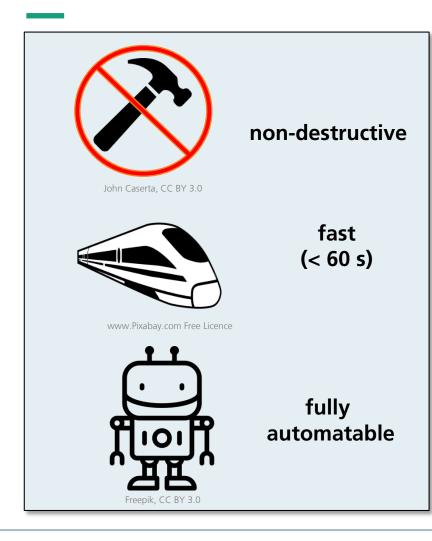








Highlights



Basics

- LAwave® Laser-induced surface acoustic waves spectroscopy
- Can access mechanical properties of coatings and surfaces
 - Integral and effective mechanical information
 - including pores, cracks and delamination
- Numerous applications for industrial quality control and R&D

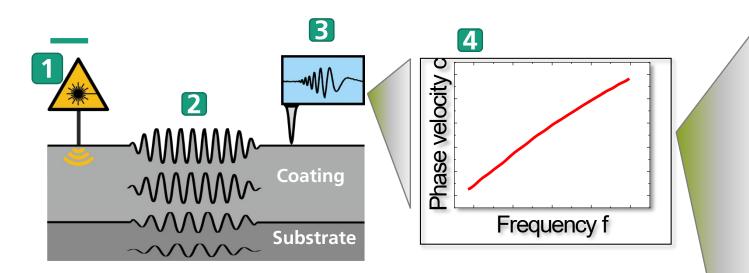
Advantages over indentation

- Faster measurement, no calibration, less consumables
- Higher precision, more and integral information
- Measures on rough surfaces
- True effective modulus: no plastic deformation, no compression of cracks, pores and defects



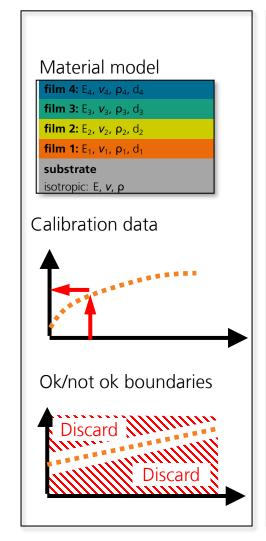


How it works - Overview



- (1) Broadband surface acoustic waves (SAW) induced by short laser pulses
- (2) SAW propagation, velocity depends on frequency
- (3) SAW measurement: piezoelectric element → digitizing oscilloscope
- (4) Fourier transformation yields velocity over frequency (dispersion curve)
- (5) Dispersion curve analysis using different evaluation strategies





Possible results

- Young's Modulus
- Density
- Depth of: Nitriding layer, Casehardening,Damage layers
- Porosity, crack density
- Delamination
- Build-up structure
- Surface hardness

.... Anything that affects your mechanical integrity of the material

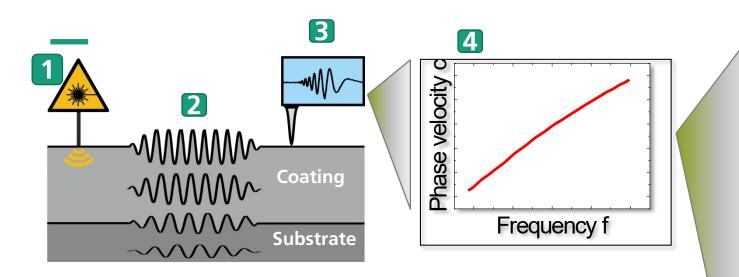




Method



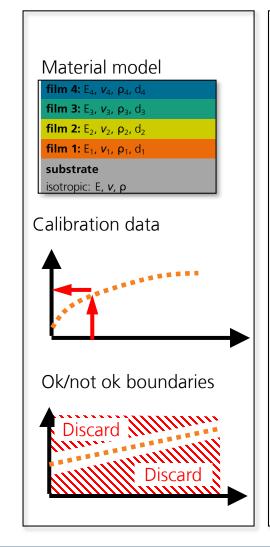
Method Overview



- (1) Surface acoustic wave (SAW) generation
- (2) SAW propagation through measured material volume
- (3) SAW measurement by piezoelectric element

- (4) Calculation phase velocity over frequency (dispersion curve)
- (5) Different analysis strategies





Possible results

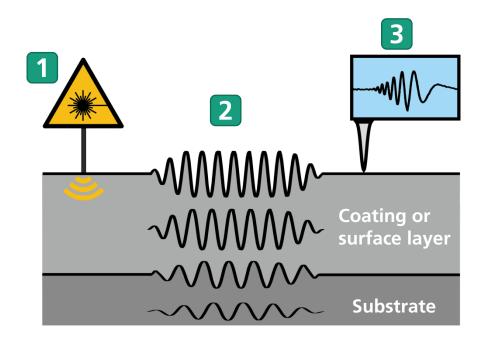
- Young's Modulus
- Density
- Depth of: Nitriding layer, Casehardening,Damage layers
- Porosity, crack density
- Delamination
- Build-up structure
- Surface hardness

.... Anything that
affects your
mechanical integrity of
the material





Surface wave excitation and measurement



1 SAW excitation

 Broadband surface acoustic waves (SAW) induced by short laser pulses

2 SAW propagation

- Penetration depth of SAW pprox wavelength $\lambda = c/f$
- SAW velocity c depends on frequency f c = c(f)

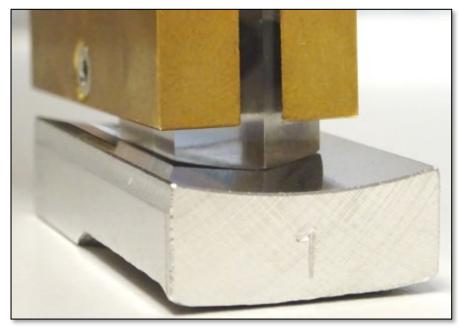
SAW detection

- Mechanical vibrations → electrical signals
 - Wedge type sensor with piezoelectric foil for 20-250 MHz
- Conventional ultra sound sensor for 1-20 MHz
- Oscilloscope measures impulse run-time



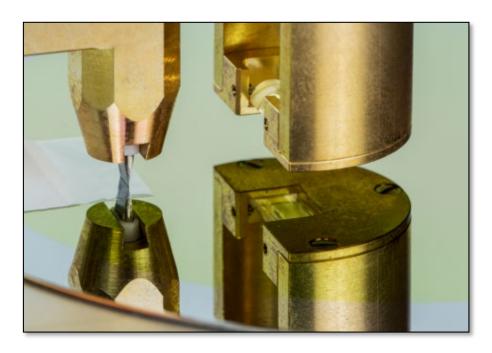
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Sensors



Low frequency

- 1-20 MHz, 20-500 µm thickness
- Thermal spray, laser cladding, surface hardening



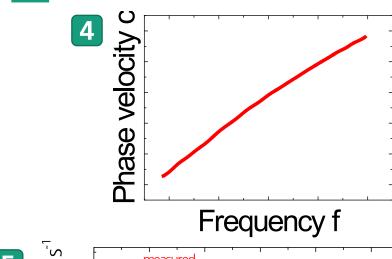
High frequency

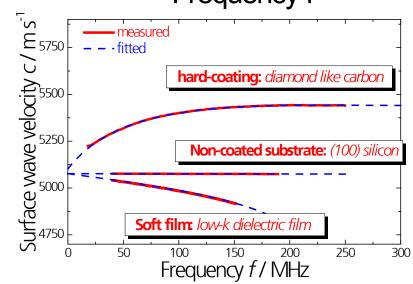
- 20-250+ MHz, \sim nanometers to 20 μm
- PVD, CVD





Evaluation of Measurement





4 Measuring procedure and data analysis

- Variation of propagation distance x
- FT of the detected signals
- \rightarrow Phase spectra $\phi(f)$ for different distances and phase velocity c(f)

$$c(f) = \frac{(x_2 - x_1)2\pi f}{\Phi_2(f) - \Phi_1(f)}$$
 = dispersion curve

 Shape of the dispersion curve c(f) depends on elasticity, density and film thickness

5 Approaches to get film properties

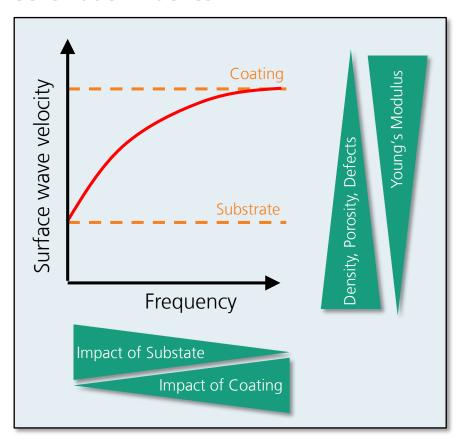
- Fitting measured curve to theory, using a material model
- Calibration with another method
- Defining ok/not ok boundaries from known samples
- Using regression fitting and KI with know samples





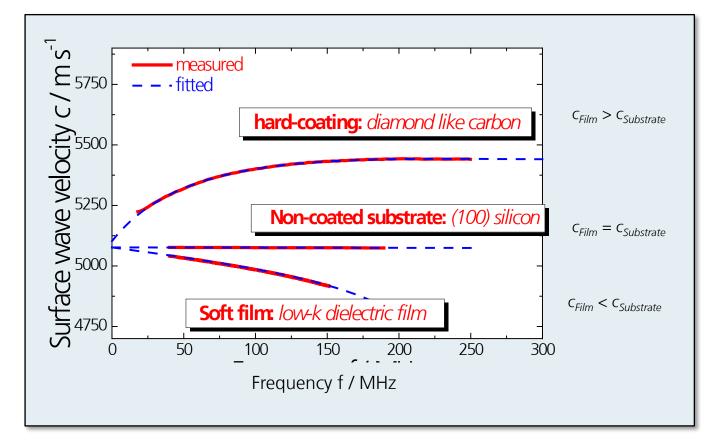
Dispersion Curve – Influence of Material System

Schematic influence



© Fraunhofer IWS

Actual influence measured on coated silicon wafer



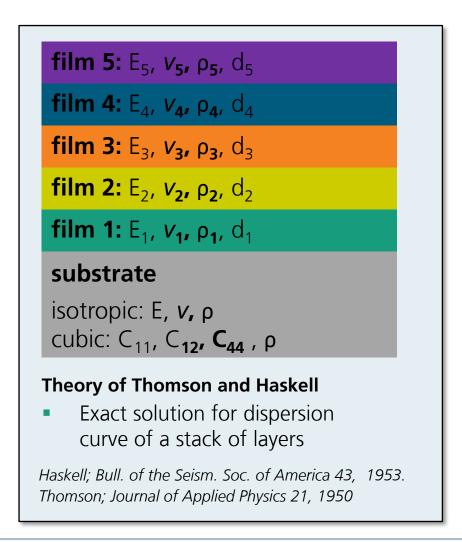




Dispersion Curve Analysis – Multilayer Material Model

Multilayer Model by Haskell and Thomson

- Is able to model SAW propagation for any multilayer stack consisting of homogeneous layers
- 1 to 3 material parameters can be obtained from fitting data to model
- Number of material parameters that can be fitted depend on curvature of dispersion curve
- Other parameters can be derived from data bases, independent measurement or assumption





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Dispersion Curve Analysis – Number of independent parameters

Material

Coating: ta-C = superhard amorphous carbon

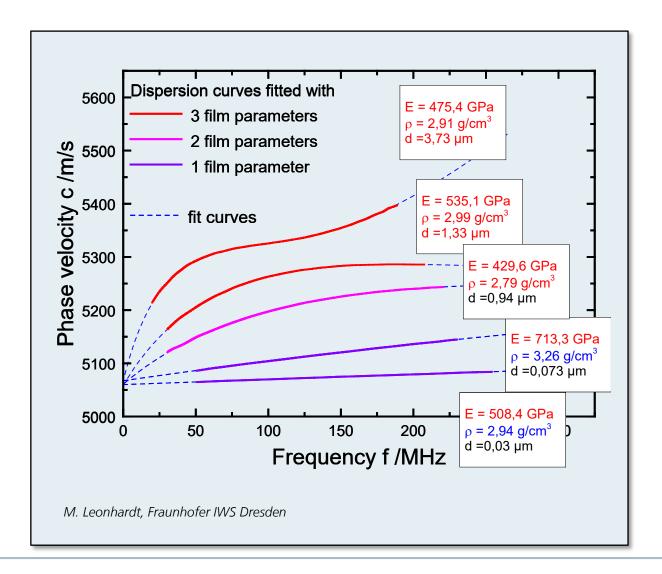
Substrate: Si wafer

Film parameters that can be measured

- Young's modulus E
- Density ρ
- Film thickness d

More coating parameters can be fitted for

- High differences of coating and substrate
- High frequency range



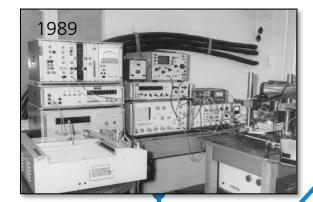




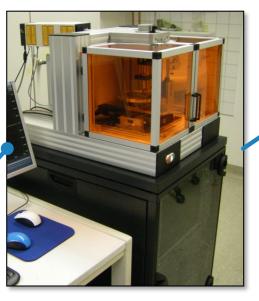
Development and Background



History of System Development

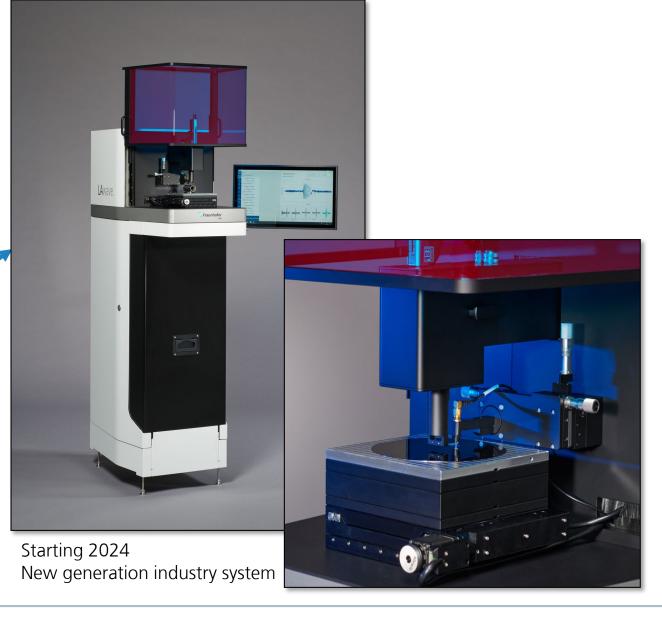


From 2016



2000s



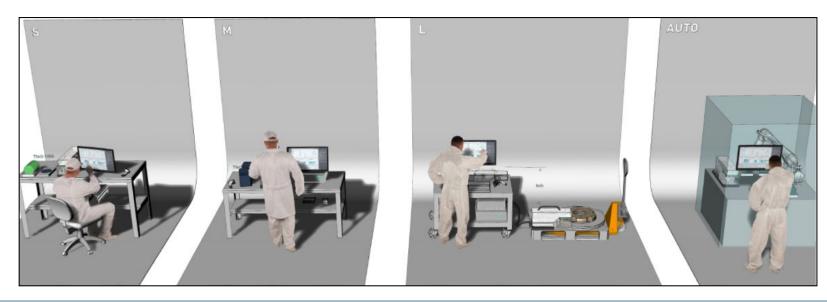




Current Developments

Development topics

- Quality control suitability: automated measurement and evaluation functionality
- Mobile head for robot or hand for measurement on large parts
- Measurement at elevated temperature
- Integration for customer-specific applications



Scaling concept for LAwave system technology

From left to right

- Fully manual operated R&D tool
- Half-automated quality control system
- Quality control system for large components
- Fully automated quality control tool





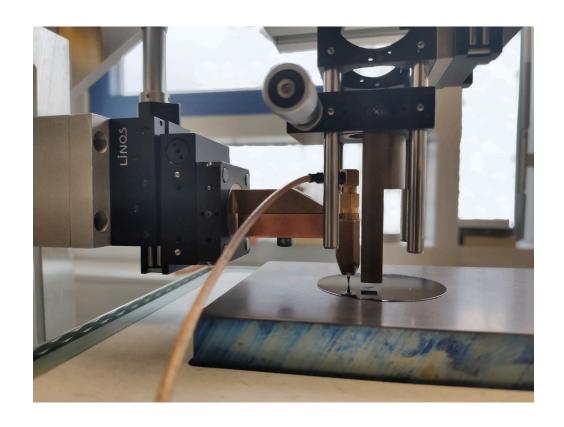
Technology Readiness

State of the art

- Standalone system, manual handling, quality control concepts - TRL 9
- 30+ systems world wide

Current development

- Automated measurement and evaluation TRL 4
- In-situ measurement up to 600 °C TRL 4
- Mobile head for robot or hand for measurement on large parts – TRL 4 (public funded project 2023-2026)
- Integration for customer-specific applications







Case Studies





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Application - Overview

Young's modulus, thickness, density of

- All kinds of coatings: PVD, CVD, spin coating, thermal-spraying, cladding, electroplating, ...
- E.g. amorphous carbon coatings (DLC), nitrides, carbides, oxides, other ceramics
- Metal films
- Low-k films
- Polymeric sensor films
- Bulk materials, e.g. steel, brass, cemented carbide
- Si, GaAs semiconductors

Depth of

- Subsurface damage from silicon wafer processing
- Surface hardening zones e.g. after metal finishing





Case study: Very thin films < 10 nm

Material

PVD coatings with thickness < 10 nm

Results

Measurement of Young's Modulus

HfO₂
 220.4 GPa

Native SiO₂39.8 GPa

■ SiO_x 41.7 GPa

• a-C 373.4 GPa

TiAIN 142.8 GPa

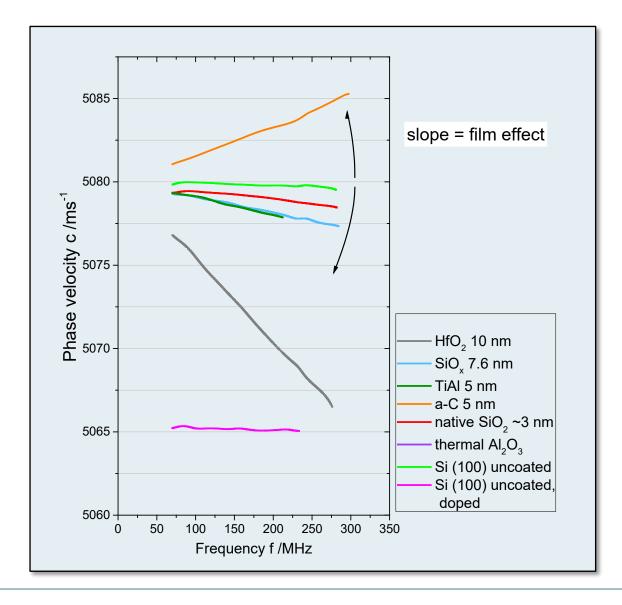
Silicon wafer 165.2 GPa (C11)

Silicon wafer (high doping)162.9 GPa (C11)

Measurement of thickness of Si/Al/Al₂O₃ multilayer stack

Thermal Al2O33.9 nm

→ Possibilities beyond nanoindentation







Case study: Subsurface damage in semiconductor wafers

Material

Semi-conductor surfaces, damaged from processing

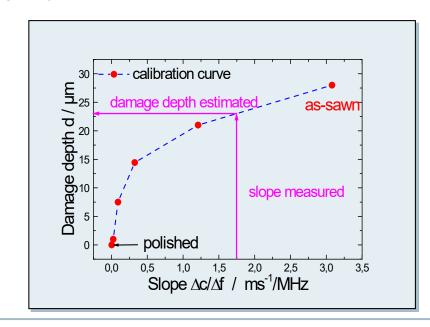
Results

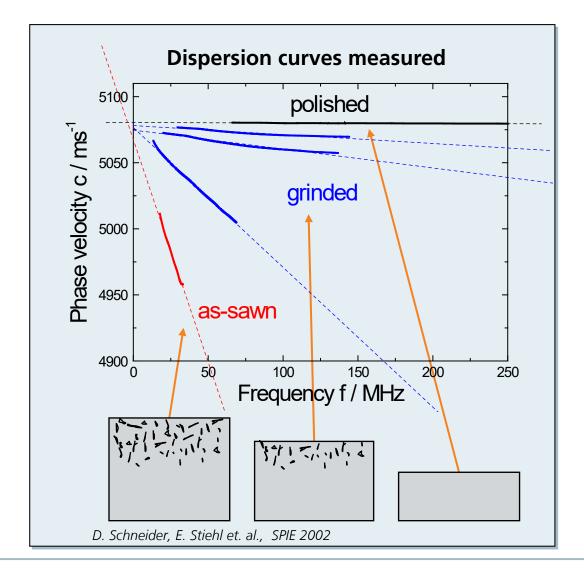
Damage layer → dispersion

27.09.2024

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Slope = damage layer depth → allows quantification









Public

Case study: Quality control of superhard carbon coatings

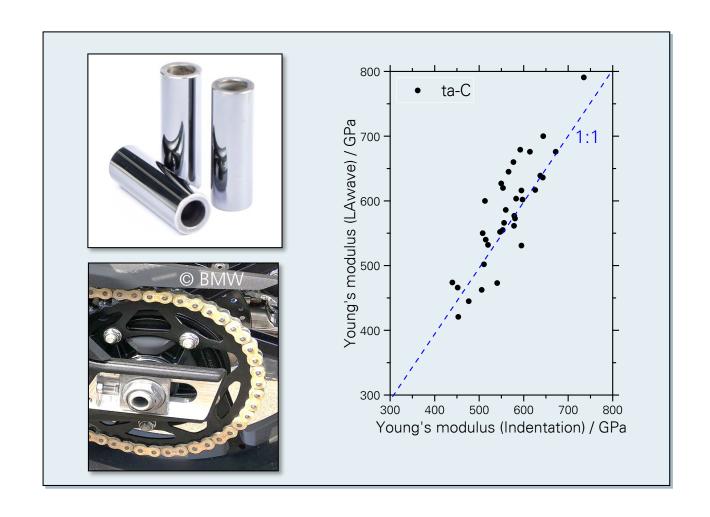
Material

- Superhard amorphous carbon coatings (ta-C, Hfree DLC), hardness 40..70 GPa
- Application: Low-wear low-friction coating, e.g. piston pins in ICE, motorcycle chain
- State-of-the art: Nanoindentation → slow and error-prone technique with high indenter wear

Results

- LAwave allows to access.
 - Coating modulus, coating hardness
 - Coating thickness

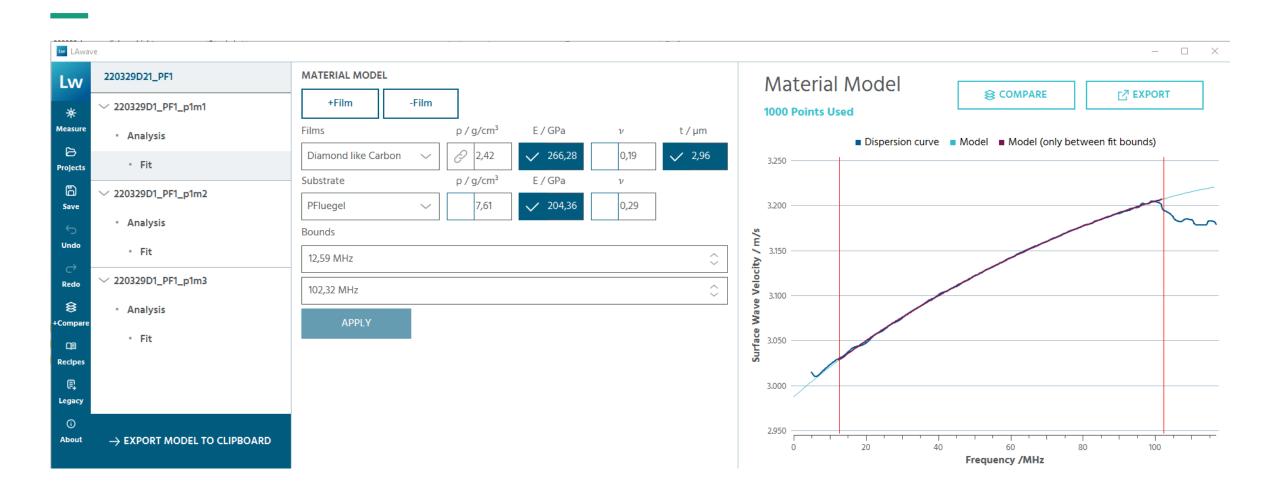
in less than 60 seconds







Case study: Quality control of superhard carbon coatings III







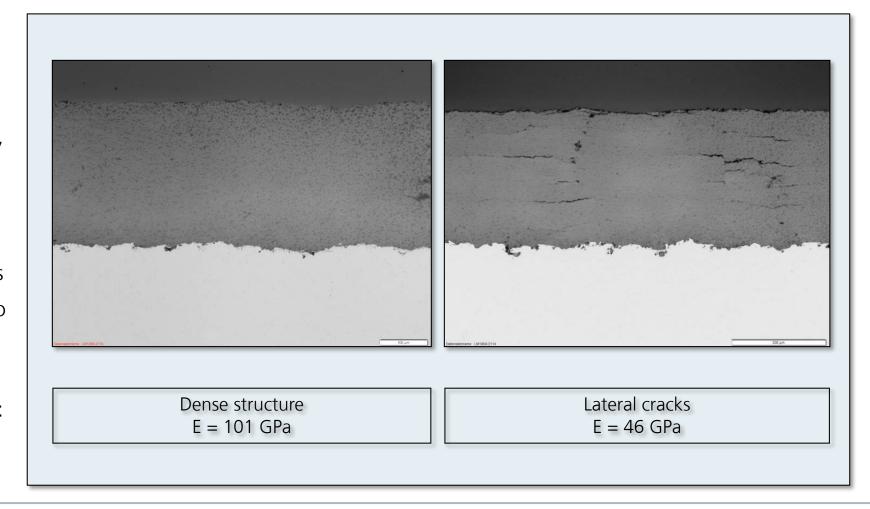
Case study: Lateral cracks in SHVOF coatings

Material

- Al_2O_3 SHVOF sprayed
- Thickness around 400 μm
- Coating structure: homogenous, risk of lateral cracks

Results

- Measurement of elastic modulus
- Elastic modulus decreases due to lateral cracks
- → Non-destructive measurement of critical defects







Case study: Development of novel brake disk coatings

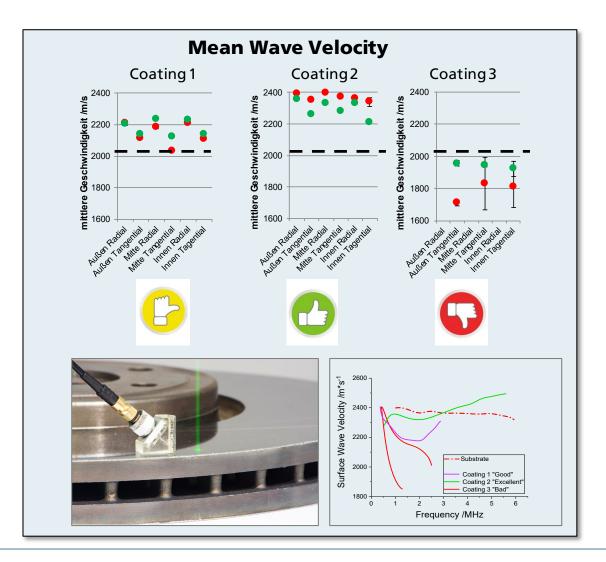
Material

- Multilayer coatings from high speed laser cladding, carbides in Fe-based matrix
- Application: Novel brake disk coatings for high performance and e-mobility
- State-of-the-art: Cross section + SEM imaging → time consuming (~ hours... days), expensive, big infrastructure

Results

- LAwave measures mechanical key features
- Front and back, ⊥ and || to deposition direction, anywhere on the disk
- Non-destructive (disk can be measured before and after test bench)
- six representative spots measured in less than 30 minutes

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Public

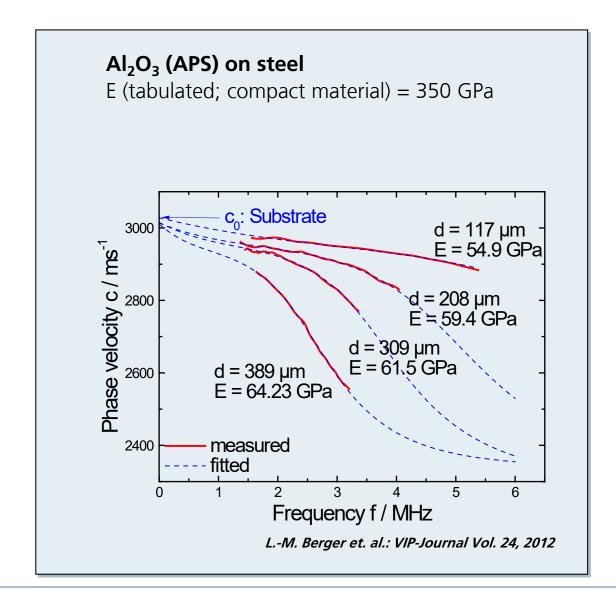
Case study: Defects in APS-Al₂O₃

Material

- Spray technologies: APS (or HVOF, ...)
- Al₂O3 (or Cr2O3, TiO2, ...)
- Thickness 100 to 600 μm
- High roughness Ra > 1 μm
- Coating structure: micro-cracks and porosity

Results

- LAwave measurement gives coating thickness and effective elastic modulus E
- Effective elastic modulus varies due to different crack and pore density
- → Quality and mechanical behavior of coating can be measured non-destructively







Case study: Pores in metal films (1/2)

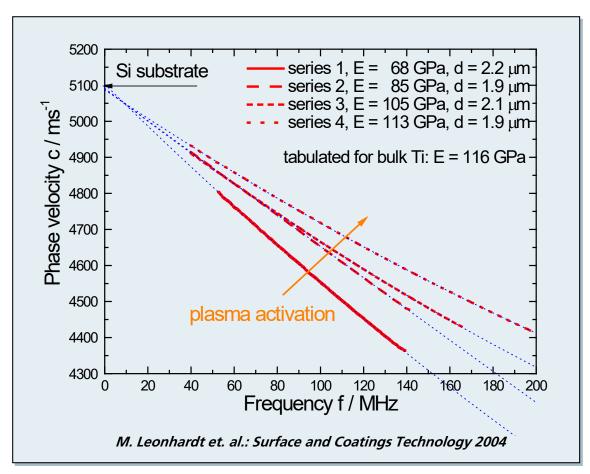
Material

- 2 μm Titanium coating on Si wafer
- PVD: Electron beam evaporator + additional plasma activation



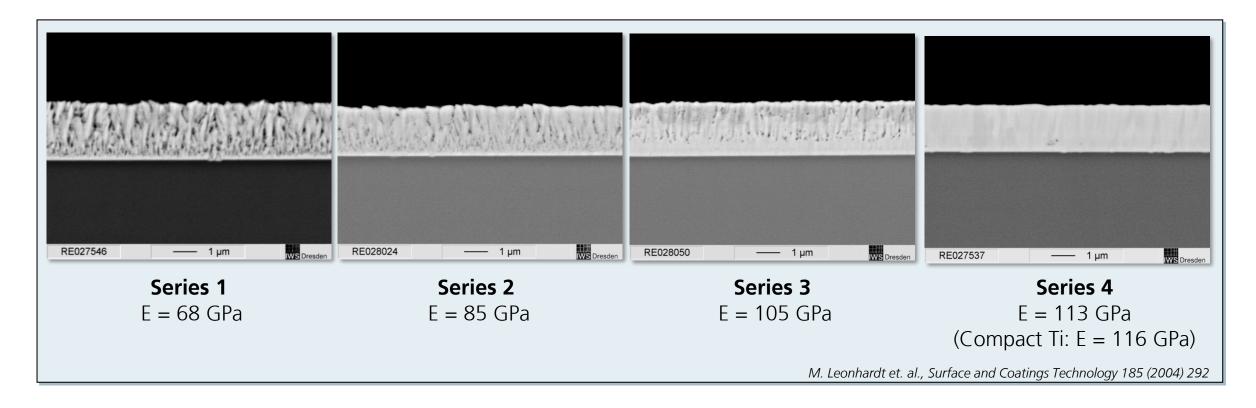
Results

- Effective Young's Modulus is measure of porostiy
- No activation \rightarrow porous films (E = 68 GPa)
- High activation \rightarrow dense films (E = 113 GPa)





Example: Pores in metal films (2/2)



→ Effective Young's Modulus strongly correlates with porosity observed in SEM cross section





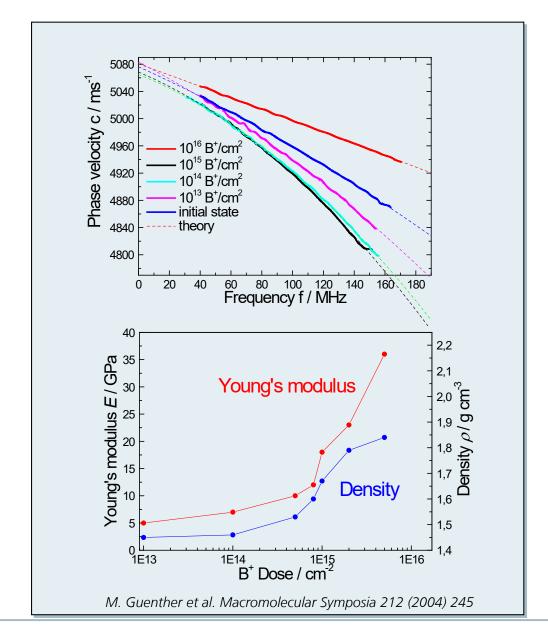
Case study: Polymeric sensor films

Material

- Polyimide films on silicon wafer for humidity sensors
- Film thickness 500 to 600 nm
- B+ ion implantation to improve sensor properties

Results

- Young's modulus E and Density ρ were obtained from the measurement
- Density and Young's modulus increase with B+ dose
- Distinct effect for a B+ dose > 1015 B+/cm²
- Young's modulus increased by approx. 700 %



Public





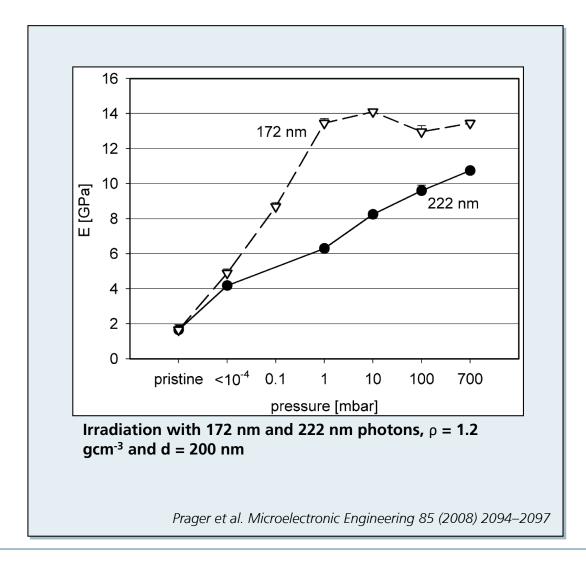
Example: Porous low-k films

Material

- Nano-porous SiCOH low-k films
- High porosity: > 40 %
- Rel. permittivity k < 2.5
- Minimum required stiffness E > 5 GPa

Results

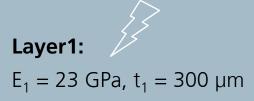
- Young's modulus and density can be measured
- Higher reliability than results from nanoindentation







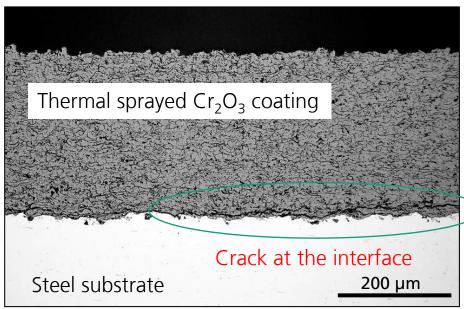
Case study: Delaminations



Steel substrate

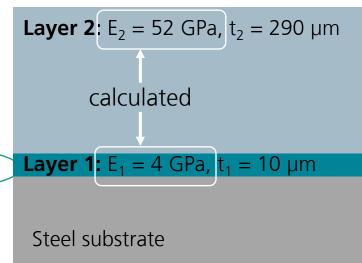
1st step: simple 1-layer model

- Measured Young's modulus smaller than expected (E = 50 GPa)
- → Measurement and model do not fit



2nd step: cross section preparation

Delamination revealed at interface



3rd step: 2-layer model

 2-layer model fits expectation when weak interface is assumed





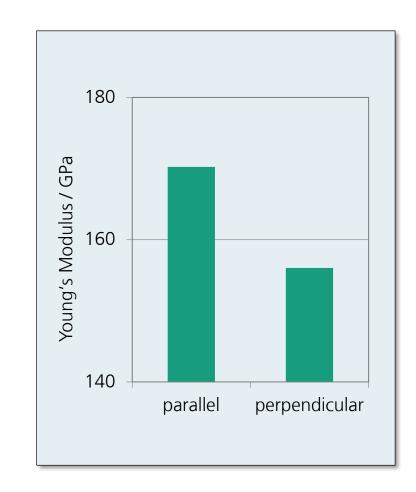
Case study: Laser cladding, laser buildup welding

Material

- Coatings from Laser Cladding on steel, thickness: 0,5 ... 2 mm
- Bulk samples from Laser Buildup Welding
- e.g. Inconel 625, 316 L
- High roughness Ra > 1 μm

Results

- Young's Modulus from measurement
- Influence of buildup direction (⊥ or || to cladding lines)
- Microstructure: Influence of cracks and porosity













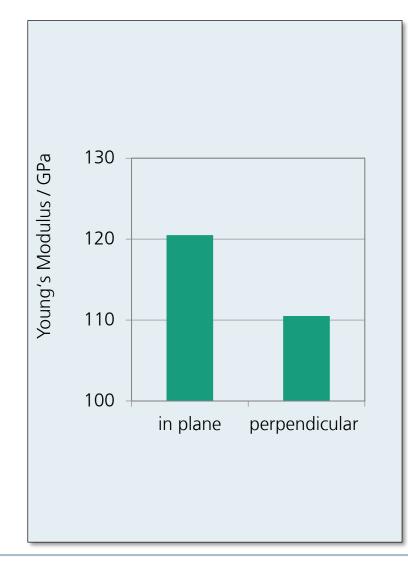
Case study: Parts generated from Selective Laser Melting (SLM)

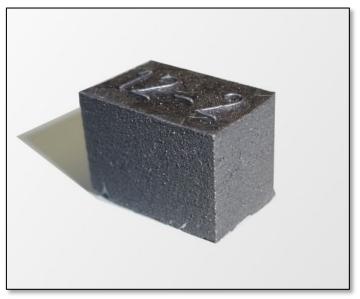
Material

- Parts generated by selective laser melting
- Material: e.g. AlSi40, Ti6Al4V, ...

Results

- Young's modulus
- Influence of buildup direction (⊥ or || to built up lines)
- Microstructure: Influence of cracks and porosity







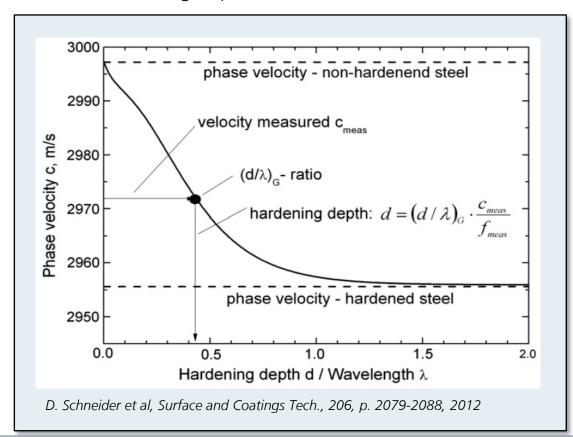


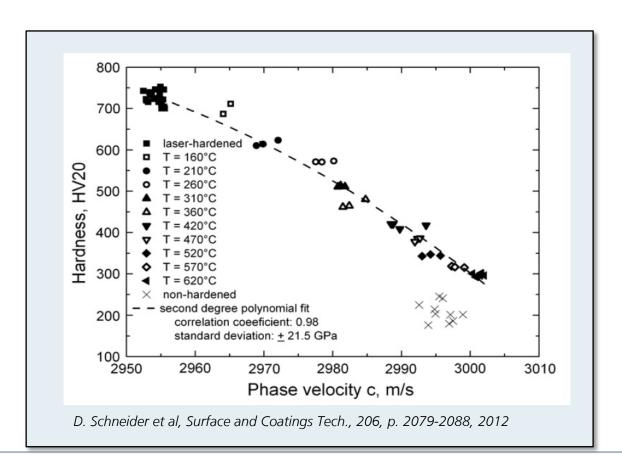


Case study: Hardening depth

Material: Surface hardened metal (case hardening, laser hardening, nitrogen hardening, ...)

Results: Hardening depth, surface hardness









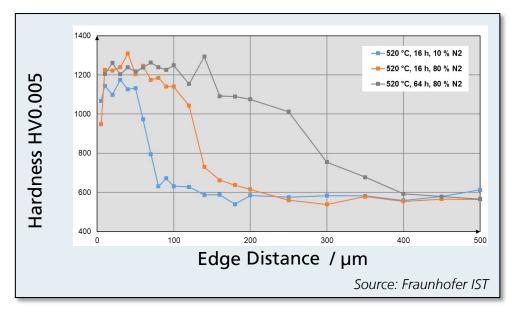
Case study: Nitriding depth

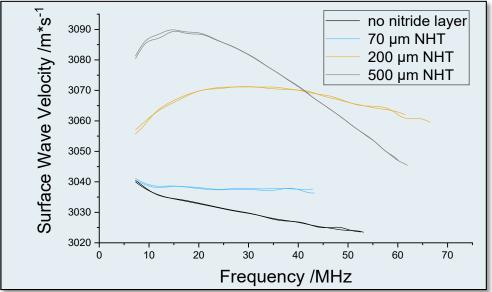
Material

- Steel 1.2343
- Nitrided with different nitride hardening depths (= NHT)

Results

- Strong correlation between hardness profile and dispersion curves
- Dispersion curves hold information about NHT, surface and core hardness, and more









Methodical Aspects



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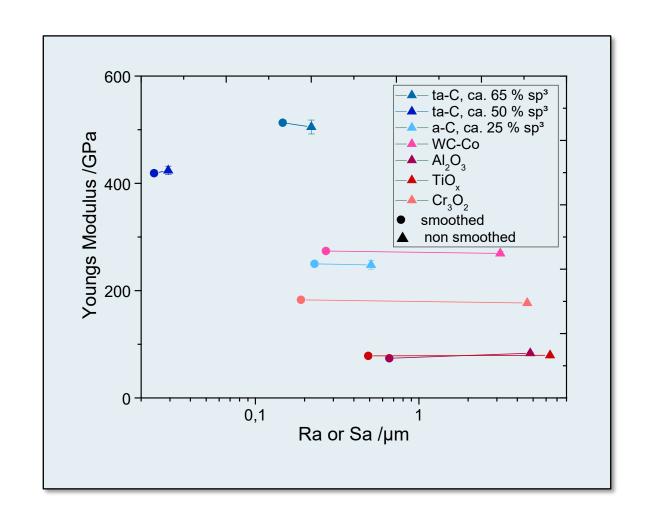
Measurement on native rough surfaces

Material

- Various hard PVD and thermal spray coatings
- Surfaces both as-deposited and smoothed

Results

- Measurement on both surfaces conditions possible
- Young's Modulus does not change
- Condition: Roughness (Ra 0,02 6,5 μm) << wave length (ca. 50 μm @ 60 MHz)
- → Measurement on native rough surfaces as reliable as on smooth surfaces







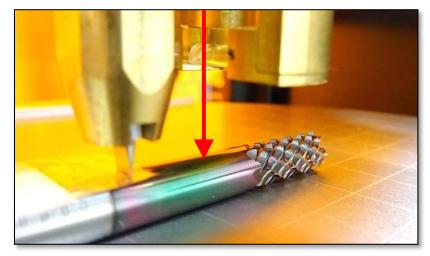
Influence of sample curvature

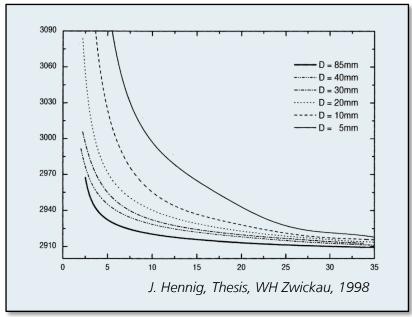
Measurement in axial direction

- No limitations from curvature
- Signal/noise ratio smaller

Measurement in radial direction

- Additional dispersion from curvature at low frequencies
- Correction of the influence of curvature mathematically possible
- **→** No general limitations from sample curvature
- **→** Practical limitations for complex 3D structures









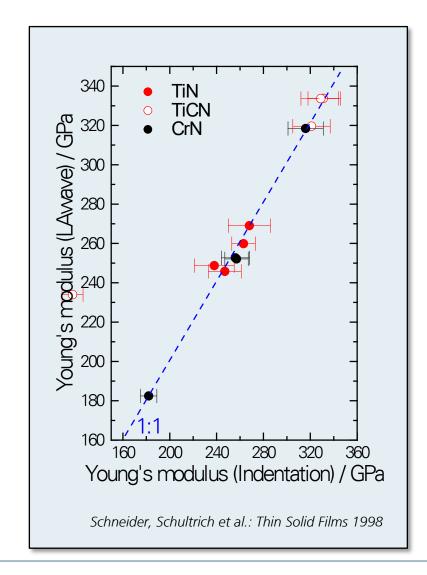
Comparison with instrumented indentation testing

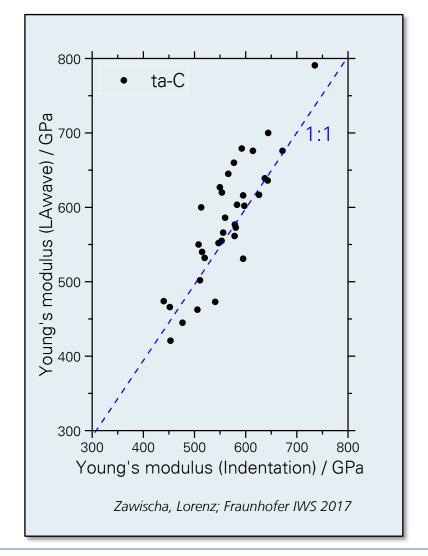
Coating Materials

- TiN, TiCN, CrN (magnetron sputtering)
- ta-C (LaserArc)
- Film thickness: d >1 μm

Result

 Excellent agreement of Young's Modulus from both methods for solid, non-porous bulk materials









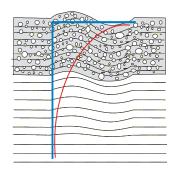
Comparison with instrumented indentation testing

Coating Materials

Porous low-k films

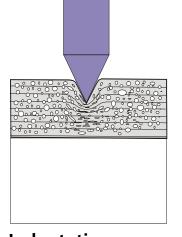
Result

Effective modulus is strongly overestimated with indentation due to compressed pores

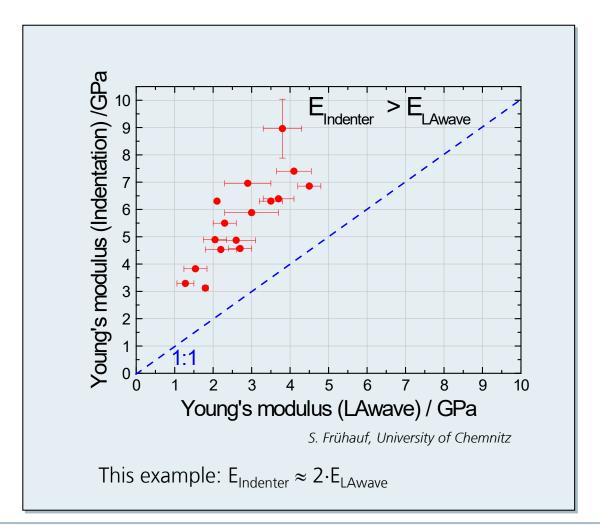


Surface acoustic waves Reversible deformation

→ True elasticity



IndentationDensification of microdefects→ Distorted results







Comparison with instrumented indentation testing (nanoindentation)

	LAwave	Nanoindentation
Method	Dynamic: Sound velocity c ~ √(E/ρ)	Quasi-static: E _r ~ dP/dh
Measuring area	> 5 x 5 mm² (integral method)	< 10 µm² (local method)
Measuring time	One minute	~ 1 hour (including sample preparation and calibration)
Minimal film thickness	A few nanometers	≈ 100 nanometers
Surface roughness	No requirements	Smooth surface necessary
Difficult material systems	Transparent and high damping materials	Soft and superhard materials, very thin coatings

→ LAwave method has superior benefits over nanoindentation for many application scenarios





Limits

Method will not work

- If surface (coating or substrate) does not absorb laser light → no wave generated
- Substrate is too thin → plate waves instead surface waves
- Damping is too high → polymers, very high roughness, very high crack density

Challenging

- On curved surfaces
- On very small areas
- Complex coating architectures, gradient (limited quantification)





LAwave around the world

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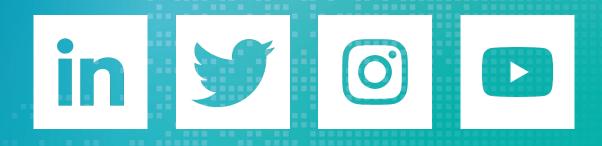
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